



USFP417-D1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Jason M. Benz

Serial No.: 09/695,028

Group Art Unit: 1765

Filed: October 24, 2000

Examiner: Alanko, Anita K.

For: METHOD FOR THIN FILM LASER REFLECTANCE CORRELATION FOR  
SUBSTRATE ETCH ENDPOINT

Honorable Commissioner of Patents  
Alexandria, Virginia 22313-1450

**SUBMISSION OF PROPOSED DRAWING CORRECTIONS**

Sir:

Submitted herewith are proposed drawing corrections, marked in red, to Figure 1A-3B. If approved, such corrections will be incorporated into the formal drawings at the time of allowance.

Approval and acknowledgment of receipt are respectfully requested.

Respectfully submitted,

Sean M. McGinn

Registration No. 34,386

Date:

6/30/03

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